| Electronic Patent Application Fee Transmittal | | | | | | | | |
|---|--|----------|----------|--------|-------------------------|--|--|--|
| Application Number: | 09864376 | | | | | | | |
| Filing Date: | 25-May-2001 | | | | | | | |
| Title of Invention: | Plasma processing apparatus and plasma processing method | | | | | | | |
| First Named Inventor/Applicant Name: | Tadahiro Ohmi | | | | | | | |
| Filer: | Charles M. Marmelstein/Charles Pace | | | | | | | |
| Attorney Docket Number: | 107176-00007 | | | | | | | |
| Filed as Large Entity | | | | | | | | |
| Utility under 35 USC 111(a) Filing Fees | | | | | | | | |
| Description | | Fee Code | Quantity | Amount | Sub-Total in USD(\$) | | | |
| Basic Filing: | | | | | | | | |
| Pages: | | | | | | | | |
| Claims: | | | | | | | | |
| Miscellaneous-Filing: | | | | | | | | |
| Petition: | | | | | | | | |
| Patent-Appeals-and-Interference: | | | | | | | | |
| Post-Allowance-and-Post-Issuance: | | | | | | | | |
| Extension-of-Time: | | | | | | | | |

| Description | Fee Code | Quantity | Amount | Sub-Total in USD(\$) |
|---|----------|----------|--------|-------------------------|
| Miscellaneous: | | | | |
| Submission- Information Disclosure Stmt | 1806 | 1 | 180 | 180 |
| | Tot | 180 | | |